

ABSTRACT

The invention provides a semiconductor apparatus provided with at least one set of buried
5 channel type first conductive type MOS transistor and
surface channel type first conductive type MOS
transistor on the same substrate, in which a first
conductive type impurity region is provided below a
gate electrode of the buried channel type and surface
10 channel type MOS transistors and between source drain
regions. Further, the invention provides a solid
state image pickup device having a photoelectric
conversion portion and a pixel including a plurality
of transistors formed in correspondence to the
15 photoelectric conversion portion, in a substrate,
wherein the plurality of transistors includes a
buried channel type first conductive type MOS
transistor and a surface channel type first
conductive type MOS transistor, and a first
20 conductive type impurity region is provided below a
gate electrode of the buried channel type and surface
channel type MOS transistors and between source drain
regions.

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